

PATENT  
MIC04 P-106

VIA FACSIMILE 1-703- 872-9310

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau  
Group : 1763  
Confirmation No. : 4253  
Applicant : Imad Mahawili, PhD  
Serial No. : 09/488,309  
Filed : January 20, 2000  
For : REACTOR WITH REMOTE PLASMA SYSTEM AND  
METHOD OF PROCESSING A SEMICONDUCTOR  
SUBSTRATE

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

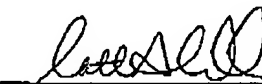
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Dated: September 19, 2002

  
Catherine S. Collins  
Registration No. 37 599  
VAN DYKE, GARDNER,  
LINN & BURKHART, LLP  
P.O. Box 888695  
2851 Charlevoix Drive, S.E.  
Grand Rapids, Michigan 49588-8695  
(616) 975-5500

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